

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Akihiko ISHIBASHI, et al.

Serial No.: 10/017,389

Filed: December 18, 2001

For: METHOD FOR FABRICATING SEMICONDUCTOR, METHOD  
FOR FABRICATING SEMICONDUCTOR SUBSTRATE, AND  
SEMICONDUCTOR LIGHT EMITTING DEVICE

: Group Art Unit: 2818

: Examiner: MAI HUONG C. TRAN

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Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

Sir:

The undersigned attorney, being of record in the subject application, hereby  
authorizes SOKBAN CHAU and VIRGINIA CLICK to inspect and to make copies from  
the subject application.

Respectfully submitted,

McDERMOTT, WILL & EMERY

Dated: 7/28/03

By: 

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SUBSTRATE, AND SEMICONDUCTOR )  
LIGHT EMITTING DEVICE )


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Honorable Commissioner for Patents and Trademarks  
Washington, D.C. 20231

Sir:

The undersigned attorney of record hereby authorizes Billie J. Huffman to inspect and/or make copies of the subject application including any and all documents associated therewith.

Respectfully submitted,



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